SEP 0 7 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

pplicant:

Sumio OGAWA et al.

Title:

METHOD OF MANUFACTURING SEMICONDUCTOR

DEVICES

Appl. No.:

10/044,964

Filing Date:

01/15/2002

Examiner:

Shella S. Rao

Art Unit:

2125

REQUEST FOR ACKNOWLEDGEMENT OF INFORMATION DISCLOSURE **STATEMENT**

Commissioner for Patents PO Box 1450 Alexandria, Virginia 22313-1450

Sir:

In reviewing the above-captioned application file upon allowance, the undersigned has noted that PTO Form-SB08, submitted on June 10, 2003, has not been acknowledged by the Patent and Trademark Office.

The Patent and Trademark Office is, therefore, requested to return the initialed forms to the undersigned as soon as possible.

Respectfully submitted,

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